

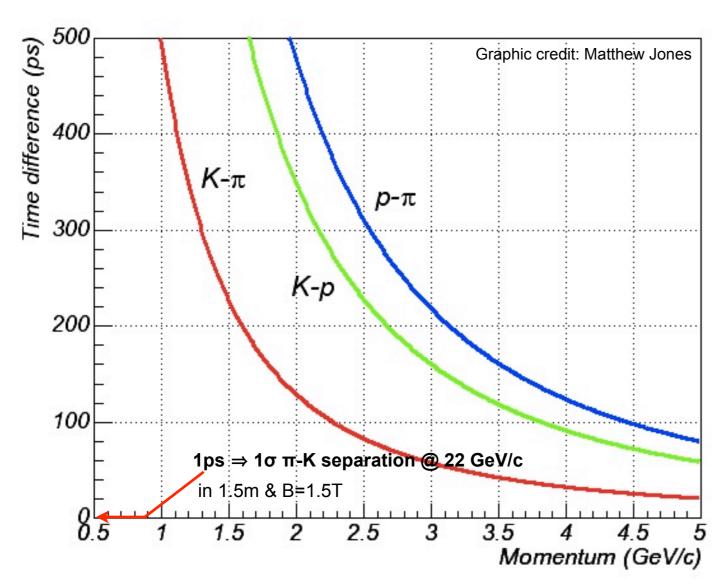
Large Area Picosecond Microchannel Plate Photodetectors

Bob Wagner
Argonne HEP Division
Tuesday 04 Sept 2012
for the LAPPD Collaboration



Motivation — Pushing the Limits of Time Resolution

Project evolved from LDRD to improve Particle ID in colliding beam experiments



Complete particle measurement: E, p + m(PID)

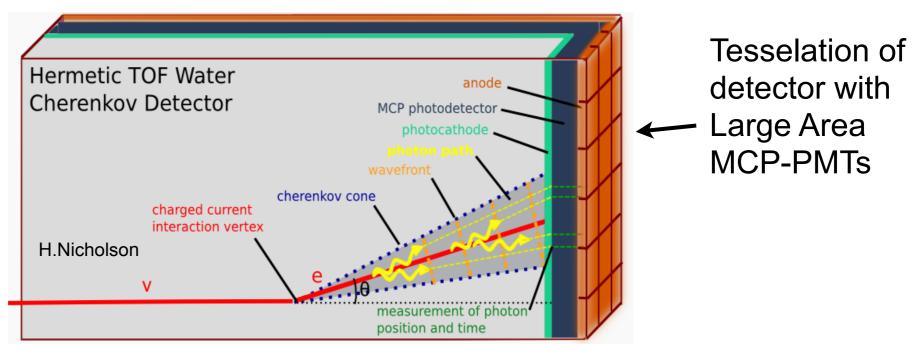
1ps time & 1mm space resolution

Goal: Measure ALL information ID quarks producing the jets. Need particle ID for momentum of 10's of GeV/c

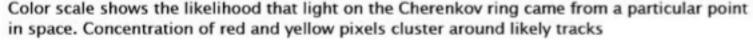


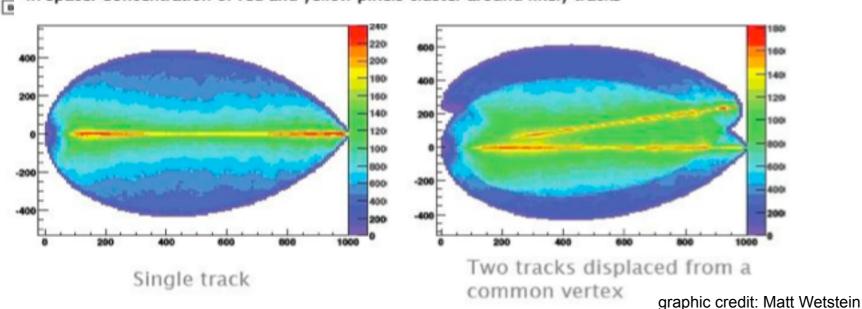
Applications — Tracking Neutrino Water Cherenkov Detector

Technique: measure arrival time and position of photons and reconstruct tracks in water



Results of a toy Monte Carlo with perfect resolution

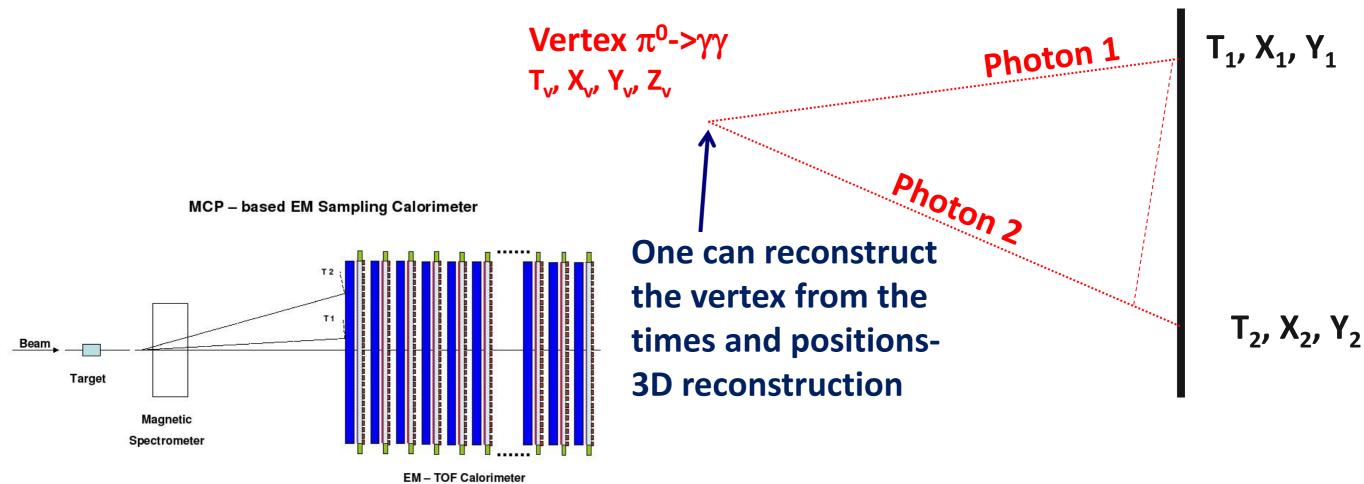




DOE Site Visit, 04 Sept 2012, Bob Wagner, Argonne HEPD

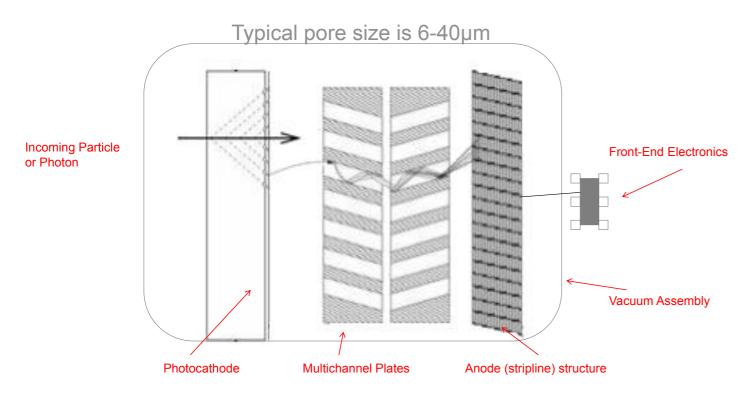
Applications — Photon Vertexing Rare Kaon Decays - $K_L \rightarrow \pi^{\circ} \sqrt{\nu}$

Combination with precision energy resolution in calorimeter critical



Reduce combinatoric background for π^{o}

Microchannel Plate Photomultipliers



Existing commercial MCP-PMTs:

- Fabrication constrained by common material for substrate, resistive and emission layers
- \rightarrow \leq ~25mm² active area
- Expensive

Components of the Large Area Picosecond Photodetector Development:

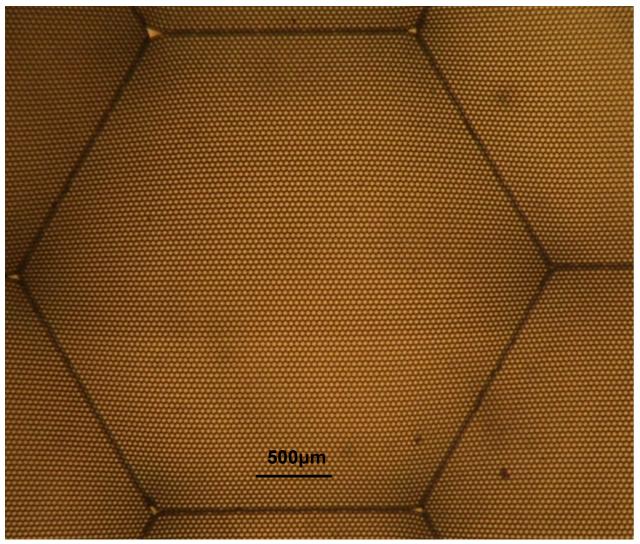
- Transformational improvement of MCP fabrication and size
 - ▶ 8"×8" borosilicate glass w/20&40µm pore
 - Resistive & secondary emissive functions separated into 2 materials via ALD coating
- Development of planar, large-area photocathodes
- Waveform sampling 10GSa/s electronics readout
- Development of economical hermetic packaging
 - Standard ceramic package w/InBi hot seal & HV/signal pins feedthru SSL/UC-Berkeley
 - Inexpensive borosilicate all-glass w/thermopressure seal, pinless Argonne/UChicago



Development of Economical Borosilicate Capillary Arrays for MCPs — Industrial Partnership w/Incom, Inc

First block 2010

Most recent block 2012



- Multifiber stacking
- Triple point gaps
- Pore crushing at multifiber boundaries

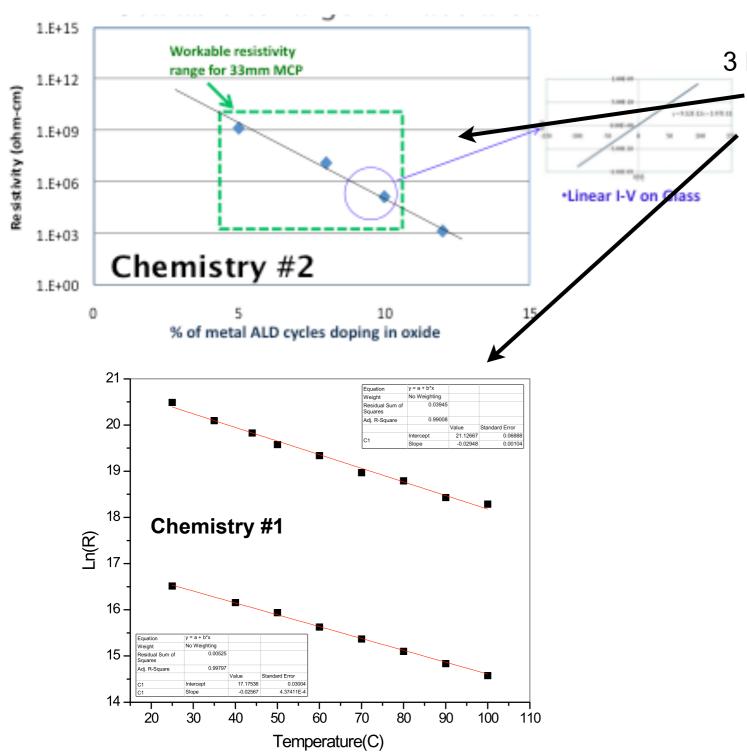
- Triple points mostly eliminated
- Minimal boundary pore distortion

Capillary array quality dramatically improved during last 2.5 years

Future: Continued fusion and finish quality improvement, reduce pore size, larger L/D, reduce production cost



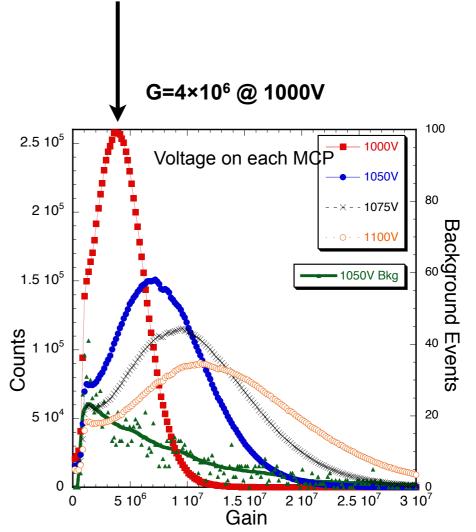
ALD Materials Development



ALD development: Anil Mane & Jeff Elam, Argonne ESD

3 Resistive Chemistries invented by ANL ALD Group:

- Tunable R over 6+ orders of mag.
- R vs. Temp. stable against thermal runaway
- Functionalized MCPs exhibit high gain



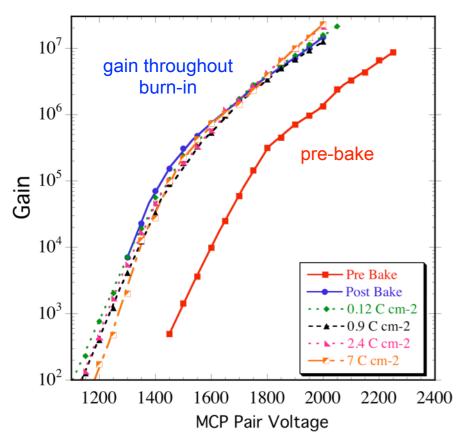
Pulse height amplitude distributions. MCP pair, 20µm pores, 8° bias, 60:1 L/d, 0.7mm pair gap with 300V bias. 3000 sec background.

graphic: Ossy Siegmund, SSL

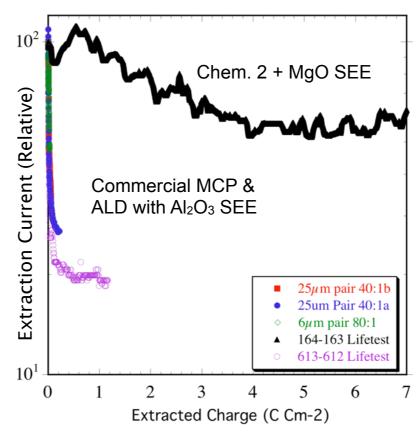
MCP Development & Testing

MCP Lifetest:

350°C bakeout then 1-3µA "burn-in" to 7C/cm²



Gain curves of 33mm ALD MCP pair during conditioning.

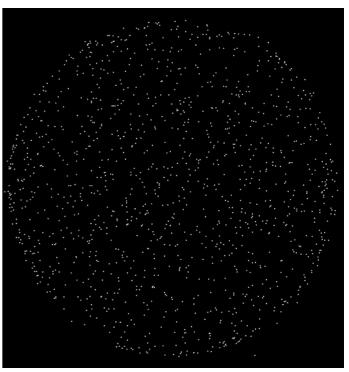


UV illumination of ALD MCP pair compared with conventional MCPs.

Desirable MCP properties with MgO SEE:

- No precipitous initial gain decrease as seen in commercial MCPs.
- Little or no aging up to 7C/cm².
- MgO SEE produces low-noise MCP

Background Noise Measurement (separate from lifetest)

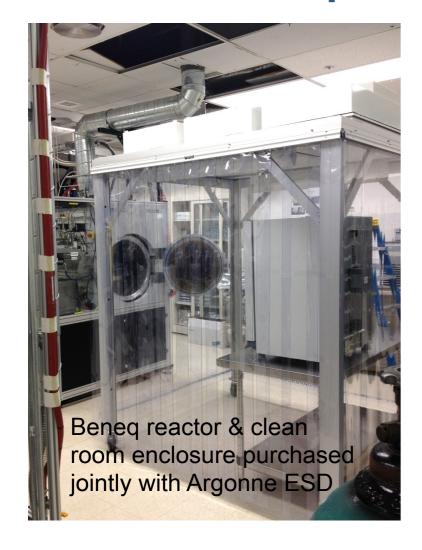


0.0845 events/cm²-s 7 x 10⁶ gain

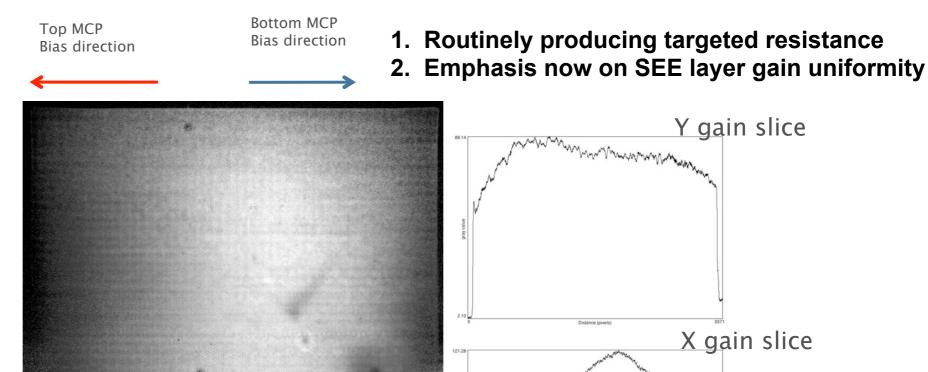
Rate comparable to cosmic bkgd

graphics: Ossy Siegmund & Jason McPhate, SSL

MCP Development — Scaling to Large Area



8" MCP Pair test at SSL



Areas of Future Focus for MCP Development

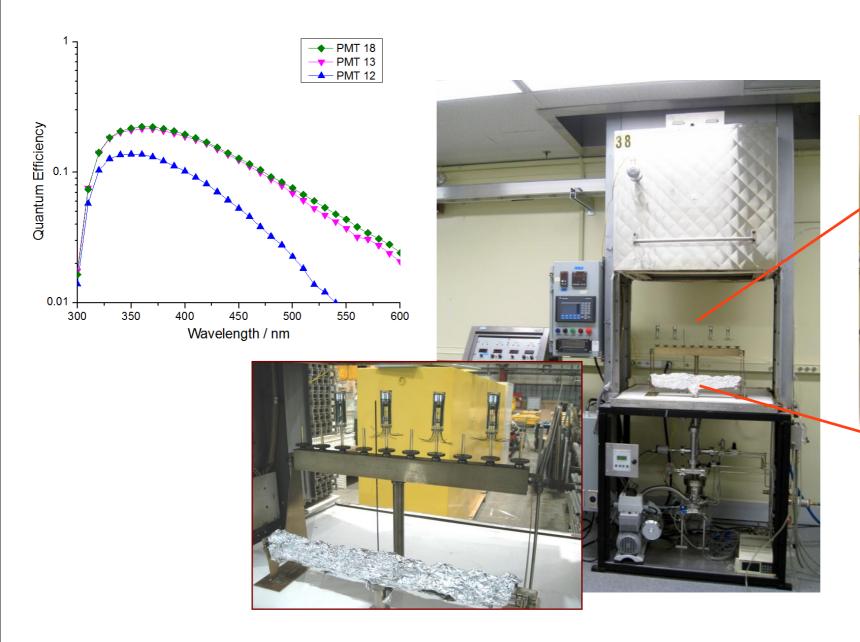
- Near term:
 - Tune ALD processing for uniform gain
 - Produce 8" functionalized plates for sealed detectors
- 3 Year Plans:
 - **Explore new ALD chemistries for lower cost, higher rate**
 - Refine ALD coating for higher throughput
 - ALD functionalization technology transfer to industry

gain meas.: Ossy Siegmund & Jason McPhate, SSL

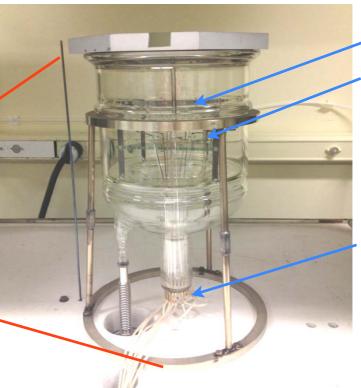
Y gain slice

X gain slice

Photocathode Development — Argonne



Learned photocathode fabrication techniques on phototube process system purchased from Burle



Sb beads

K, Cs dispensers

21-pin connector for beads, dispenser, signal wiring

Large glass vacuum vessel (**Chalice**) replaced small PMT manifold to produce 4" & 7" photocathodes

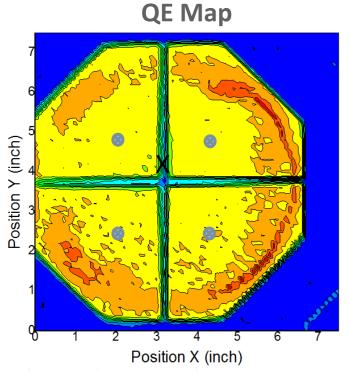
Developing techniques to scale to 8" transfer cathode for Tile Facility at Argonne

Scale-up to 7" Photocathodes at Argonne

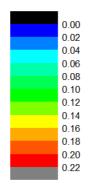


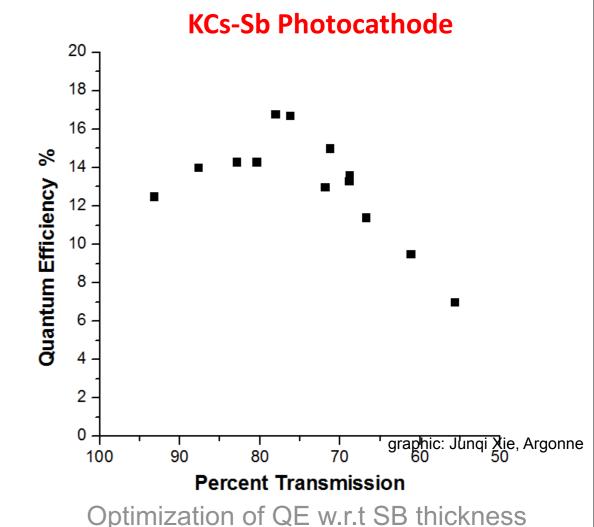
13 Photocathode shoots on "erasable" glass window:

- Tune process parameters
- Optimal # and placement of Sb, K, Cs dispensers
- Improve QE and uniformity



Chalice Photocathode #9





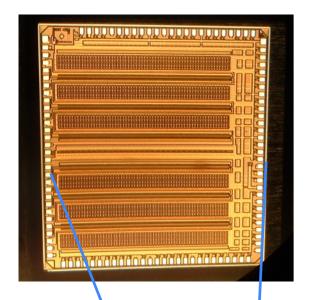
% transmission of Sb ⇒ thickness

Photocathode fabrication established at Argonne

- Ongoing study for uniformity and QE>20%
- Future:
 - transfer techniques from Chalice to 8" tube processing system at Argonne
 - Collaboration with SSL, BNL, UChicago, WashU, ... on understanding and improving photocathode QE

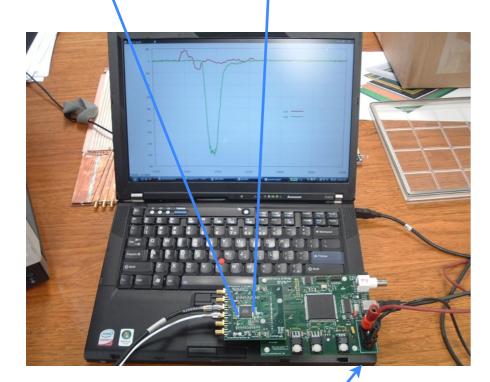


Development & Testing of Front-end Electronics

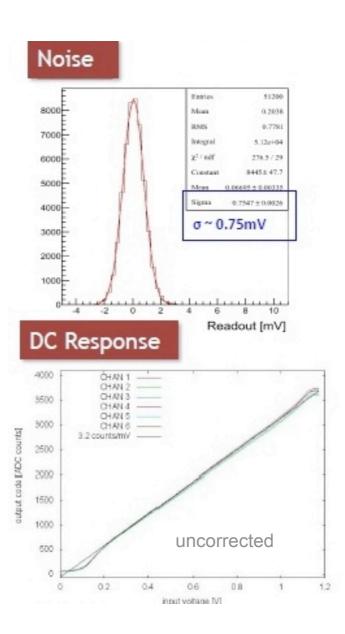


PSEC4 6-ch. "scope-on-a-chip" 1.6 GHz BW, 10-15 GSa/s, 130nm technology

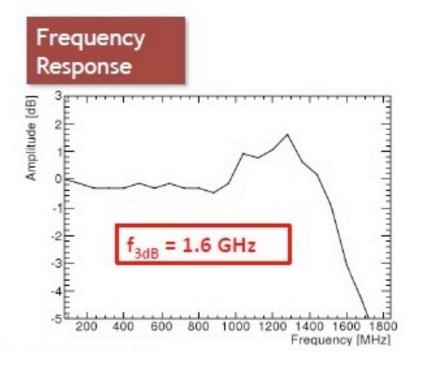
PSEC ASIC Design and Testing by Univ. of Chicago & Univ. of Hawaii



Evaluation board w/2.0 USB interface + PC DAQ software



- Low noise <1 mV
- ~1V dynamic range with excellent linearity
- Analog bandwidth of 1.6 GHz
- Sampling rates up to 15 GSa/s



PSEC 4 design & test results: Eric Oberla & Hervé Grabas, Chicago



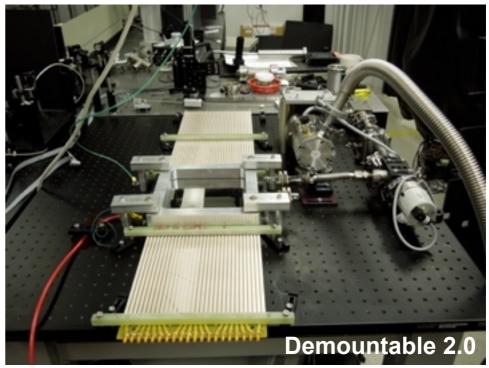
Glass MCP Phototube Strip Line Anode



Tile base is 30 strip silk-screened anode

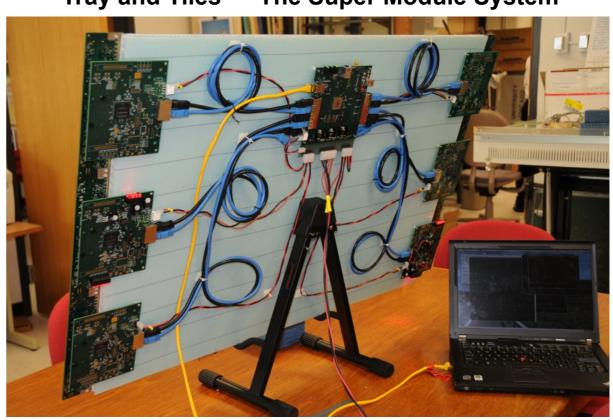


- Serial connection of tiles with common double-end readout minimally affects performance
- 4×3 array of tiles ≡ SuperModule Tray
- Complete readout chain from front-end waveform sampling ASIC through digital and central control cards to graphics processor
 PC has been integrated into SuperModule



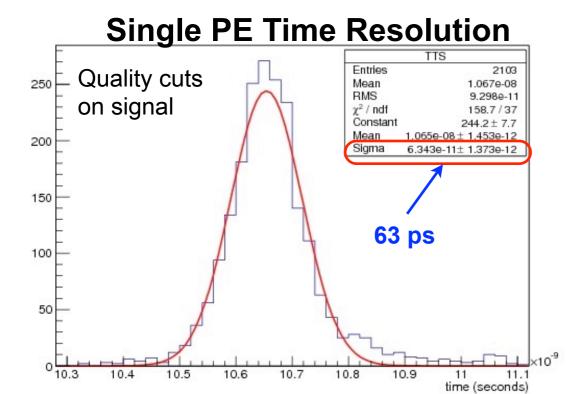
Digital & Central DAQ Boards: Mircea Bogadan & Craig Harabedian, Chicago

Tray and Tiles — The Super Module System





Strip Line Anode Performance with 8" MCP Pairs



w/double-ended readout 5.35 o 5.3 5.25 dT/dX = 10.2ps/mm5.2

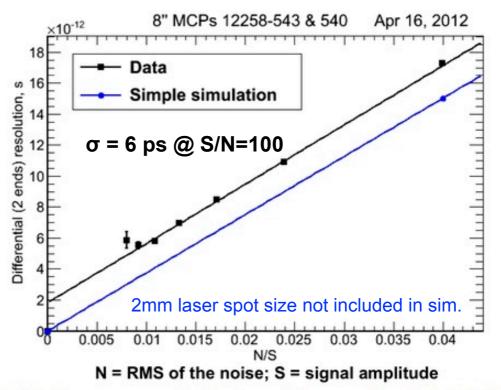
-202

-200

X, mm

Position scan along stripline

Differential Time Resolution vs. Noise

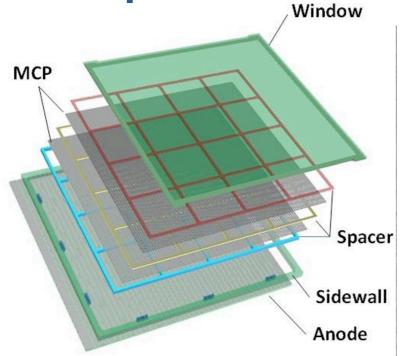


Simulation has many more points than shown. All are very well consistent with the blue line.

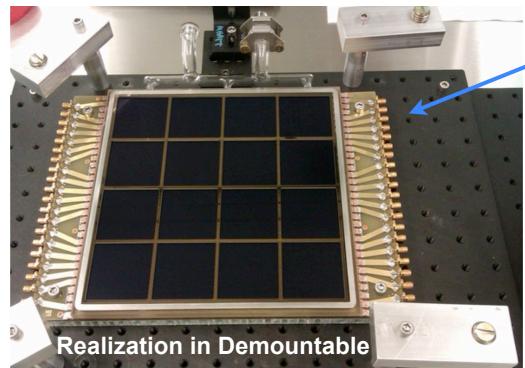
- Results from Argonne 8" Test Ch. w/UV laser excitation, fast scope readout (M.Wetstein, B. Adams, A. Elagin, R. Obaid, A. Vostrikov)
- Un-optimized Anode performance impressive and meets present needs
- Prospects for improvement to few ps resolution are good

-198

Development of Hermetic Package — All Glass Tile

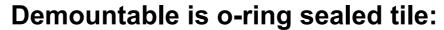


Design Drawing - September 2010



Assembled in ALD Lab
Clean Room

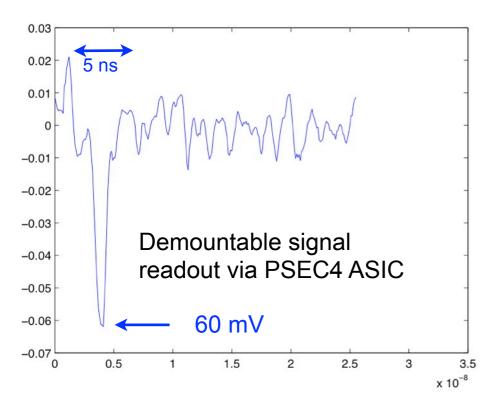
Transported to APS UV Laser Test Setup



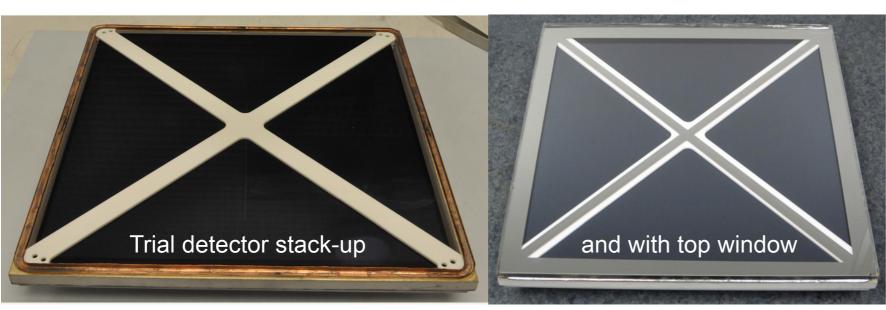
- Continuously pumped sealed tile with 8" MCP pair
- Al photocathode on quartz window
- ALD grid spacer for HV distribution
- 30-strip anode to fanout board

Future Work:

- Complete work presently ongoing for Indium pressure seal for top window
- Produce smaller format sealed tiles in existing vacuum transfer system
- Produce sealed tiles with bialkali PC in future Argonne Single Tile Processing System



Development of Hermetic Packaging — Ceramic Tube





- Process tank in commissioning
 - readying for 1st photocathode shoot in process tank; several 8" done in separate test chamber
- In/Bi seal tests in 8" test chamber
- Tile base braze progressing; ready for 3rd/final iteration
- On track for sealed tube this Fall

LAPPD Future Directions

- SBIR/STTR: At least 5 Letters of Intent from industry for 2013 FOA
 - Fully integrated sealed detector devices STTR
 - MCPs for improved spatial/time resolution
 - Theory-based high QE photocathode development
 - Non-vacuum transfer process for production of MCP-PMTs
 - PET camera development
- Tasks Requested for KA15 funding:
 - All-Glass Tile Fabrication at Argonne (eventually several 10s per year)
 - Small format (<4" sq.) with modification of existing vacuum transfer system
 - 8" Single Tile Processing System
 - Rationale: Glass tubes for distribution to HEP community; MCP, ALD, photocathode development testing, alternative formats
 - Ceramic Tile Fabrication at SSL (5–6 per year
 - Improve design and throughput
 - Improved QE
 - All-glass fabrication in SSL process tank
 - Generation II R&D (Argonne, UChicago, SSL, UHawaii)
 - Improved MCPs, photocathode, readout



Existing 4" Vacuum Transfer System at Argonne — System for Early Vetting of STF Process





Possible early STF demonstrator:

- Chambers can be coupled via existing 6" flanges to give PC process chamber and sealing chamber.
- Left system is operating now at 5×10⁻¹⁰ torr, right system is 10⁻⁸ torr
- Photocathode Transfer System will be moved to Bldg. 360 in September



LAPPD Project Summary

Capability Gap

- Existing MCPs have small effective area, are expensive, and have all properties embodied in a single medium.
- Development of large area MCP-PMTs with few ps resolution would provide a transformational tool for HEP experiments, e.g.
 - Water Č tracking detector
 - Higher momentum Particle ID
 - Pile-up vertex separation/Photon vertexing

Benefit

- Potential for picosecond time and millimeter spatial resolution photodetection over large surface areas.
- Applications within and beyond HEP.
- Re-establish U.S. photodetector development and manufacturing.
- Potential large cost savings for detectors requiring 1000s of photodetectors.

Approach

- MCP substrate, resistive, and emissive components separated into individually tunable materials.
- Less expensive borosilicate glass hermetic package
- Parallel ceramic body approach using proven techniques and expertise.
- Integrated DAQ w/Waveform Sampling ASIC frontend.
- Enabled by unique multi-disciplinary expertise and cross-divisional infrastructure at Argonne

Results and Future

- Signals from o-ring sealed complete all-glass MCP tile
- Diff. time resolution with 8" MCP pair < 6ps
- Complete DAQ system with PSEC4 ASIC;
 15 GSa/s; noise<1mV, bandwidth ~1.6GHz
- 8" Photocathode QE~25% @ 350nm & uniform & stable
- On track for sealed ceramic MCP-PMT by Fall
- Propose to construct MCP Tile Facility at Argonne to produce all-glass tiles for evaluation by HEP community
- Continue production of ceramic tiles at SSL
- PC research to achieve QE >> 25%
- Seek industrialization of photodetector through SBIR/ STTR



Backup Slides

The Large Area Picosecond Photodetector Participants During the First 3 Years

- National Labs
 - Argonne
 - HEP Division
 - Energy Systems Division
 - Nuclear Engineering Division
 - Glass Shop
 - X-ray Sciences Division
 - Materials Science Division
 - Mathematics and Computer Science Division
 - Fermilab
- Universities
 - University of Chicago
 - Space Sciences Lab/UC-Berkeley
 - University of Hawaii
 - Washington University
 - University of Illinois Chicago
 - University of Illinois Urbana/Champaign

- U.S. Companies
 - · Incom, Inc.
 - · Arradiance, Inc.
 - · Synkera Technologies, Inc.
 - · Minotech, Inc.
 - Muons, Inc.

LAPPD is a multi-disciplinary/multiinstitutional effort that draws on the unique expertise and infrastructure at Argonne and at our partner institutions

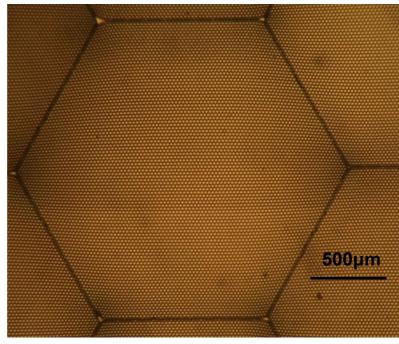
Development of Economical Borosilicate Capillary Arrays for MCPs — Industrial Partnership w/Incom, Inc

Fused block ready for slicing



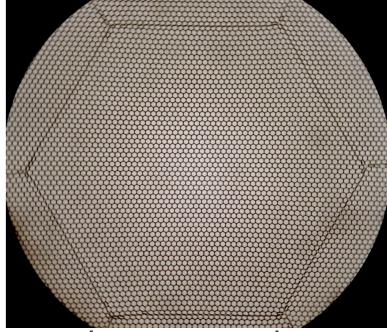


First block



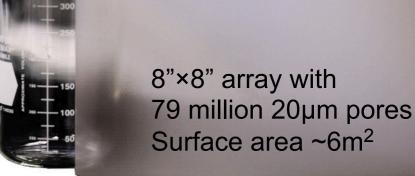
- Multifiber stacking
- Triple point gaps
- Pore crushing at multifiber boundaries

Most recent block



- Triple points mostly eliminated
- Minimal boundary pore distortion

Capillary array quality dramatically improved during last 2.5 years



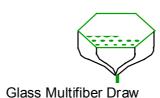
Industrial Microchannel Plate Fabrication

Glass is gravity-fed via cylindrical furnace

Glass is typically lead glass tube with solid soft glass core

Chemical processing to remove soft core glass

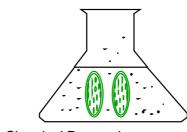






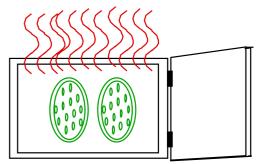


Billet Slice, Grind, Polish

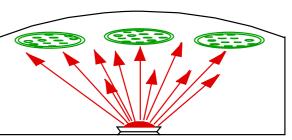


Chemical Processing

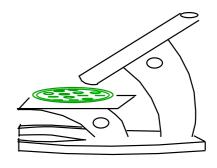
Graphic Credit: B. Laprade & R. Starcher, Burle (2001)



Hydrogen Reduction



Electrode Evaporation



Final Test & Inspection

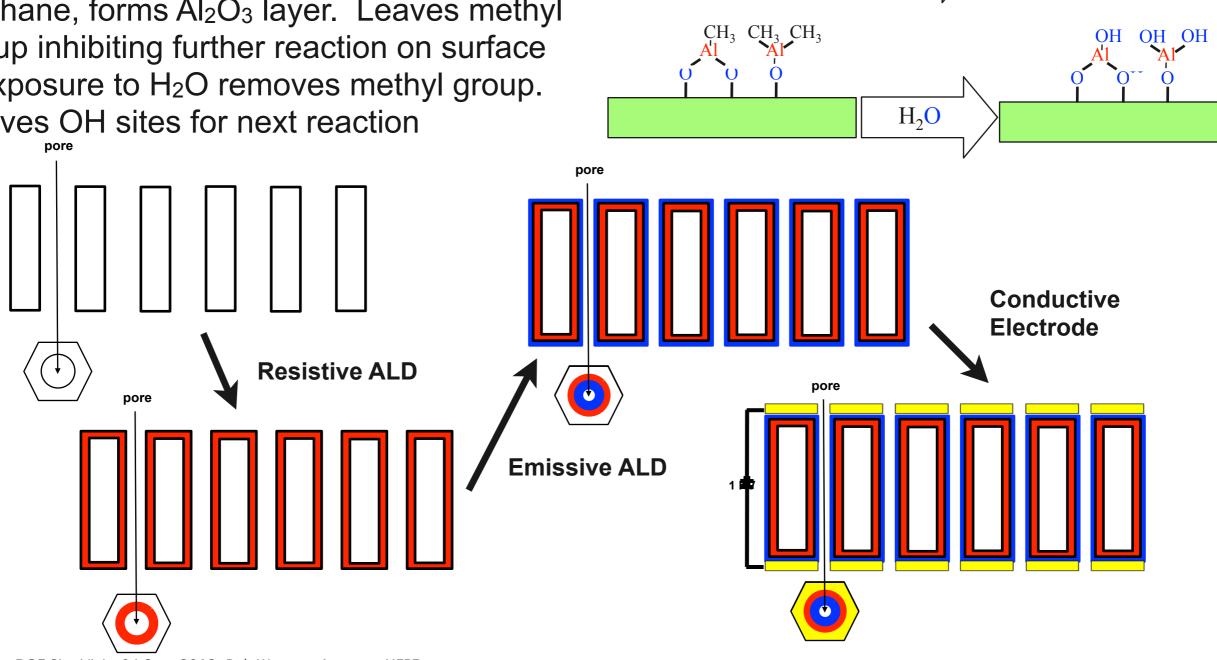
Before sealing in tube, plate must be subjected to prolonged exposure to electrons at low voltage to outgas H₂ and other material



Pore Activation via Atomic Layer Deposition (ALD)

Example:

- OH on surface provide reaction sites
- Trimethyl aluminum reacts liberating methane, forms Al₂O₃ layer. Leaves methyl group inhibiting further reaction on surface
- Exposure to H₂O removes methyl group. Leaves OH sites for next reaction



OH OH OH

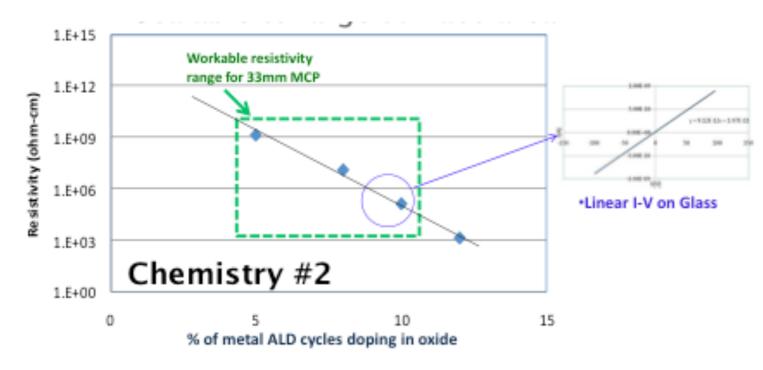
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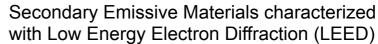
CH₃ CH₃

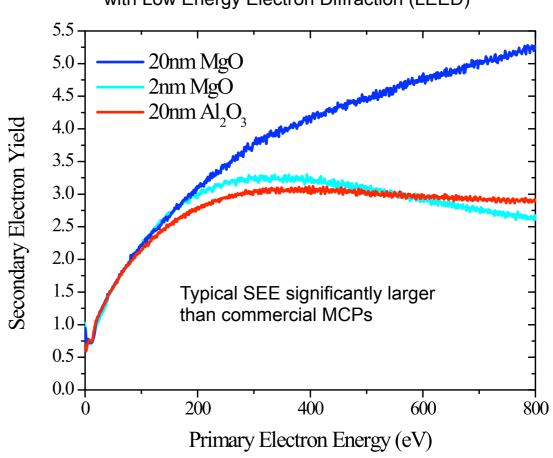
Trimethyl Aluminum (TMA)

 $Al(CH_3)_3$

Materials Characterization



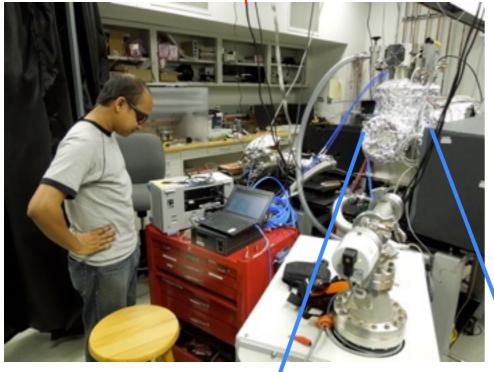






MCP Testing at Argonne and SSL — Facilities

Argonne 33mm & 8" Test Chambers with UV fs-pulse laser



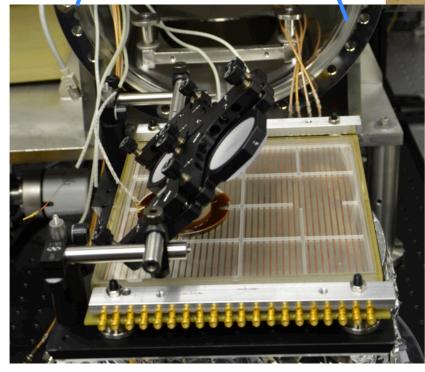
SSL 33mm Test Chambers



Phosphor detector on left imaged with camera

Cross-strip delay line on right for gain mapping

MCP on stripline anode ready for insertion into 8" chamber

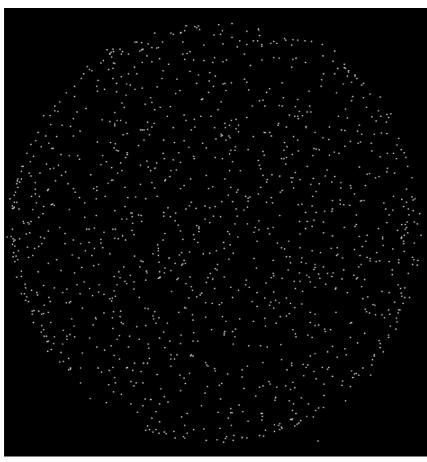


SSL 8" MCP Test
Detector Vacuum System

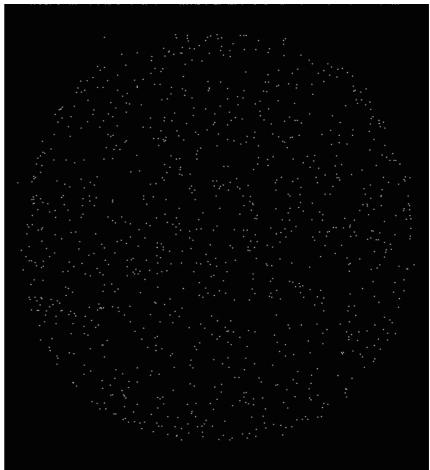


Noise Characterization

MgO SEE Layer



3000 sec background, 0.0845 events cm $^{-2}$ sec $^{-1}$ at 7 x 10 6 gain, 1025v bias on each MCP. Get same behavior for most of the current 20µm MCPs



Post-bake –2000 sec ~0.1 events cm⁻² sec⁻¹

8" Photocathode Development — SSL/Berkeley

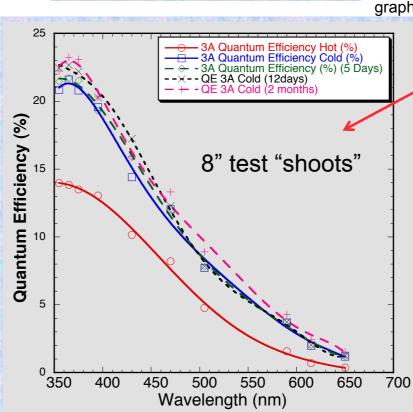
Na₂KSb Photocathode Chosen for

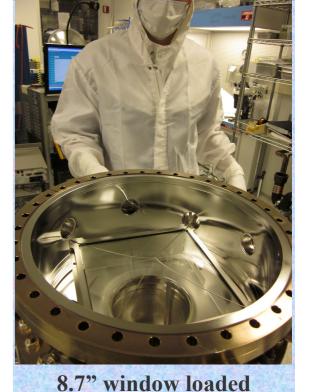
- Resistivity
- Noise
- Temperature robustness
- Uniformity

8" Photocathodes successfully produced at SSL

- Cathodes in 8" test chamber with QE~25%
- Uniformity and stability meet
 MCP tube needs
- Ready to transfer techniques from 8" test ch. to large tube processing station.



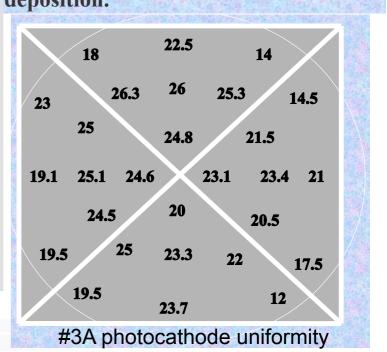




graphics: Ossy Siegmund & Jason McPhate, SSL

Basic process is a co-evap technique.

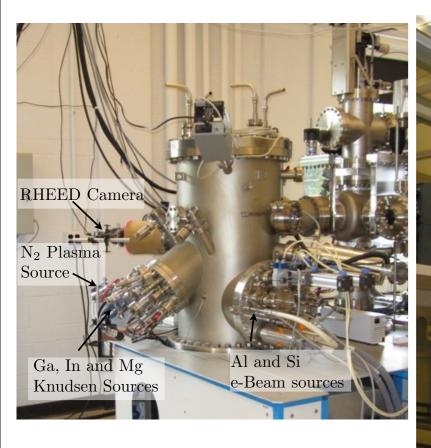
We get an enhancement of the QE
after cool-down. The QE has remained
stable over the 2 months since
deposition.

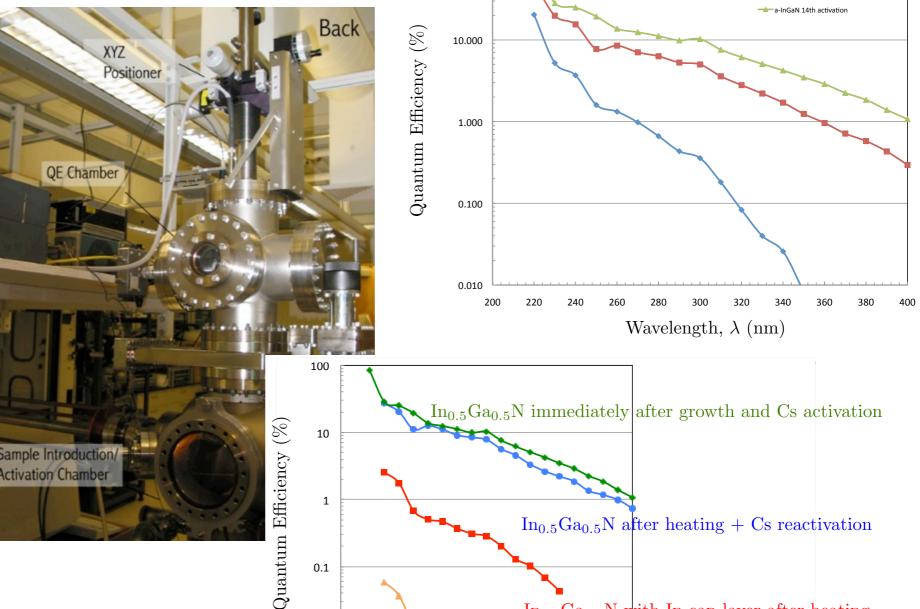


DOE Site Visit, 04 Sept 2012, Bob Wagner, Argonne HEPD

InGaN Photocathode Development — **Washington University**

> Sample Introduction/ **Activation Chamber**





10

1

0.1

0.01

0.001

200 220 240

 $In_{0.5}Ga_{0.5}N$ after heating + Cs reactivation

In_{0.5}Ga_{0.5}N with In cap layer after heating

In_{0.5}Ga_{0.5}N with In cap layer

260 280 300 320 340 360 380 400

Wavelength, λ (nm)

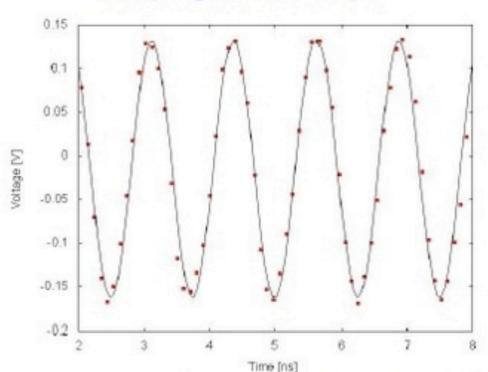
→ a-InGaN first activation

PSEC4 Performance

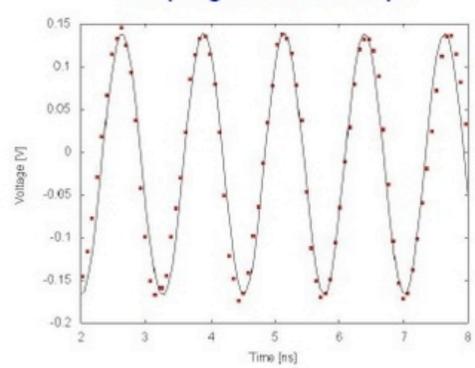
Digitized Waveforms

Input: 800MHz, 300 mV_{pp} sine





Sampling rate: 13.3 GSa/s



- Only simple pedestal correction to data
- As the sampling rate-to-input frequency ratio decreases, the need for time-base calibration becomes more apparent (depending on necessary timing resolution)



Summary of Accomplishments 2009-2012

- ☑ Developed large area capillary arrays (20µm pore, L/D=60) for MCP substrate
- Functionalized MCPs via separate Atomic Layer Deposition resistive and secondary emissive coatings
 - Demonstrated high gain (> 10⁷) with little aging
 - Success recognized with R&D100 award 2012
- Characterization of SEE materials within Argonne MSD
- **☑** Established MCP test facilities at Argonne and SSL/UC-Berkeley
- ☑ Developed detector-to-computer DAQ based on PSEC4 ASIC with 1.6GHz BW, 10-15 GSa/s
- Timing resolution: 6ps differential, 63ps single pe
- **☑** 8" photocathodes (SSL) with QE~25% @ 350nm with good uniformity & stability
- Established photocathode lab at Argonne and made first 4"&7" photocathodes
- Toemonstrated signals from o-ring sealed all-glass economical tile at Argonne
- Process tank for 8" ceramic tube at SSL ready for commissioning
- Completing ceramic body braze at SSL and on-track for working sealed tube in Fall 2012
- ☑ Development of 4×3 tile SuperModule tray with complete readout chain



Milestone yet to be achieved

